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Bib Data Sheet

CONFIRMATION NO. 7966

SERIAL NUMBER 10/608,404	FILING DATE 06/26/2003  RULE	CLASS 205	GROUP ART UNIT 1742	ATTORNEY DOCKET NO. AMAT/5699/P3/CMP/CMP/RKK
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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 10/038,066 01/03/2002 PAT 6,811,680  
 which claims benefit of 60/275,874 03/14/2001,  
~~and is a CIP of 10/032,275 12/21/2001 PAT 6,899,804~~  
 a CIP of 10,378,097 02/26/2003  
 which claims benefit of 60/359,746 02/26/2002,

and is a CIP of 10/456,220  
 06/06/2003.

11/09 12-30-2005

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/17/2003

Foreign Priority claimed <input type="checkbox"/> yes, <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>nee C Lee</i> 12-20-2005 Examiner's Signature Initials	CA	4	36	3

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## TITLE

Method and composition for polishing a substrate